



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of:

Hartwell, et al.

Serial No.: 10/066,213

Filed: 2/1/02

Group Art Unit: 2823

Examiner: Julio J. Maldonado

Docket No. 10006165-1

For: **METHODS FOR DICING WAFER STACKS TO PROVIDE  
ACCESS TO INTERIOR STRUCTURES**

**RESPONSE**

Mail Stop: AF  
Assistant Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The Advisory Action mailed June 9, 2004 has been carefully considered. In response thereto, please enter the following amendments and consider the following remarks.

**AUTHORIZATION TO DEBIT ACCOUNT**

It is not believed that extensions of time or fees for net addition of claims are required, beyond those which may otherwise be provided for in documents accompanying this paper. However, in the event that additional extensions of time are necessary to allow consideration of this paper, such extensions are hereby petitioned under 37 C.F.R. § 1.136(a), and any fees required therefor (including fees for net addition of claims) are hereby authorized to be charged to deposit account no. 08-2025.